



제 32회 한국반도체학술대회

The 32nd Korean Conference on Semiconductors

2025년 2월 12일(수)-14일(금) | 강원도 하이원리조트

Future Normal in Semiconductor

2025년 2월 13일(목), 09:00-10:45

Room J(스페이드 II+III), 6층

G. Device & Process Modeling, Simulation and Reliability 분과

010_[TJ1-G] TCAD Simulation

좌장: 장지원 교수(연세대학교), 백록현 교수(포항공과대학교)

초청 TJ1-G-1 09:00-09:30	Impact of Random Discrete Dopants on 6F² DRAM Cell Transistors: A Simulation Study Jaehyun Lee School of Electrical and Electronics Engineering, Pusan National University
TJ1-G-2 09:30-09:45	Effect of Metal-Capping Layer on Electrical Performances in a-IGZO TFTs: Experiment and TCAD Simulation Seongbin Lim ¹ , Soohyun Lim ¹ , Jaewook Yoo ¹ , Hyeonjun Song ¹ , Soyeon Kim ¹ , Hongseung Lee ¹ , Minah Park ¹ , Seohyeon Park ¹ , Sojin Jung ¹ , Jin-Ha Hwang ² , Kiyoung Lee ² , Sangmoon Yoon ³ , and Hagyoul Bae ¹ ¹ Jeonbuk National University, ² Hongik University, ³ Gachon University
TJ1-G-3 09:45-10:00	Random Phase Distribution Effects of Ferroelectric Tunneling Field-Effect-Transistors (FeTFETs) Jiwon Park and Woo Young Choi Department Electrical and Computer Engineering and ISRC, Seoul National University
TJ1-G-4 10:00-10:15	Assessment of Logic Circuit Characteristics with Contact Resistance in 2D Material-Based Complementary-FETs (CFETs) Hanggyo Jung ¹ and Jongwook Jeon ² ¹ Department of Semiconductor Convergence Engineering, Sungkyunkwan University, ² School of Electronic and Electrical Engineering, Sungkyunkwan University
TJ1-G-5 10:15-10:30	Comprehensive Analysis of Random Variability in Forksheet FETs Compared to Nanosheet FETs Minchan Kim, Seunghwan Lee, Junjong Lee, Sanguk Lee, Yonghwan Ahn, Gunryeol Cho, and Rock-Hyun Baek Department of Electrical Engineering, POSTECH



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J1-G-6

10:30-10:45

A Novel Simulation Method of Harmonic Distortion of RF Substrates using
Ramo-Shockley Theorem
Nakwon Yu, Jongmin Kim, Youngchul Kim, and Hyunchul Nah
TE Team, DB HiTek